IPAC'24 - 15th International Particle Accelerator Conference



Contribution ID: 1969 Contribution code: TUPG70

Type: Poster Presentation

Advanced utilization of a single laser source for an inverse Compton scattering system

Tuesday 21 May 2024 16:00 (2 hours)

An Yb:YAG laser has been used to generate both the electron emission from a photocathode and act as the interaction laser on a 100 MeV inverse Compton scattering experiment. The laser generates 25 mJ pulses at 1030 nm, 1.5 ps long, up to 120 Hz. 10% of the energy is sent into a Fourth Harmonic Generation (FHG) module where frequency doubling happens twice. Up to 200 μ J of adjustable Ultra-Violet (UV) laser can be exploited and sent towards the photocathode. The rest of the energy, 90% of the initial IR beam, is propagated to the interaction region. The goal is to match 1mm beam on the photocathode and 40 μ m at the interaction region with high stability. To reach it, significant effort was put into optimization using state of the art laser propagation software. We used a set of tools like low aberrations lenses, truncated Gaussian beam, vacuum transport, relay of images, and closed loop stabilization system. In the end, this project pairs strong optical and mechanical constraints. A large part of it was built and tested, showing exciting results.

Footnotes

Funding Agency

Paper preparation format

Word

Region represented

North America

Author: AMOUDRY, Loic (RadiaBeam Technologies)

Co-authors: MORO, Adam (RadiaBeam Technologies); MUROKH, Alex (RadiaBeam Technologies); DIEGO, Amirari (RadiaBeam); GAVRYUSHKIN, Dmitriy (RadiaBeam Technologies); KRAVCHENKO, Maksim (RadiaBeam); LENZ, Maximilian (Particle Beam Physics Lab (PBPL)); MATAVALAN, Nanda (RadiaBeam Technologies); BURGER, Nathan (RadiaBeam); MUSUMECI, Pietro (University of California, Los Angeles); BERRY, Robert (RadiaBeam Technologies); FOSTER, Robert (RadiaBeam); HODGETTS, Tara (RadiaBeam)

Presenter: AMOUDRY, Loic (RadiaBeam Technologies)

Session Classification: Tuesday Poster Session

Track Classification: MC2: Photon Sources and Electron Accelerators: MC2.T25 Lasers